

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	09618165	CHOI ET AL.
	<b>Examiner</b>	<b>Art Unit</b>
	Jade R. Chwasz	2872

### SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
359	489	7/17/08	JRC
359	489,497	5/7/09	JRC

### SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Consulted with Primary Arnel Lavarias	2/4/08	JRC
359/493, 483, 485, 487, 488, 500 with text	6/30/08	JRC
Text search	6/30/08	JRC
Consulted with Primary Arnel Lavarias	7/30/08	JRC
Consulted with Primary Arnel Lavarias	12/30/08	JRC
Updated search in EAST	5/7/09	JRC
Consulted with Primary Arnel Lavarias	5/7/09	JRC
Consulted with Primary Arnel Lavarias	10/28/09	JRC
Consulted with Primary Arnel Lavarias	3/16/10	JRC
Consulted with Primary Arnel Lavarias	7/8/10	JRC

### INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

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